

Supplementary Information

Correlation Among PEDOT:PSS Film Microstructural Crystallinity/Composition, Electrochemical Transistor Performance, and Long-Term Stability

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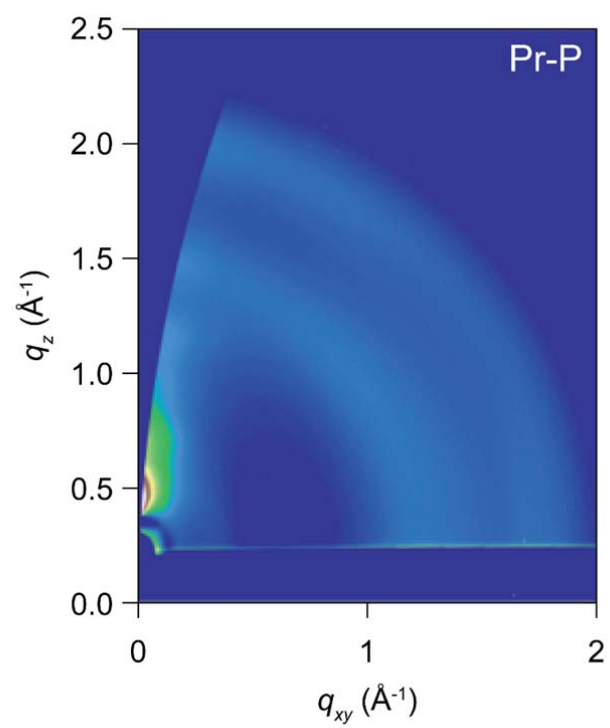
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This Supplementary Information includes: Supplementary Figures 1 to 8 and Supplementary Tables 1 to 2



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30 **Supplementary Figure 1.** Grazing incidence wide-angle x-ray scattering (GIWAXS)

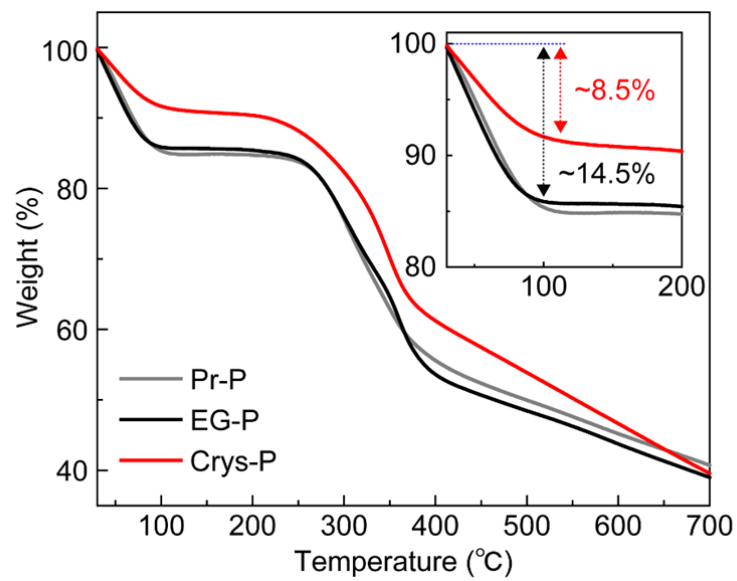
31 patterns of a pristine PEDOT:PSS (Pr-P) film.

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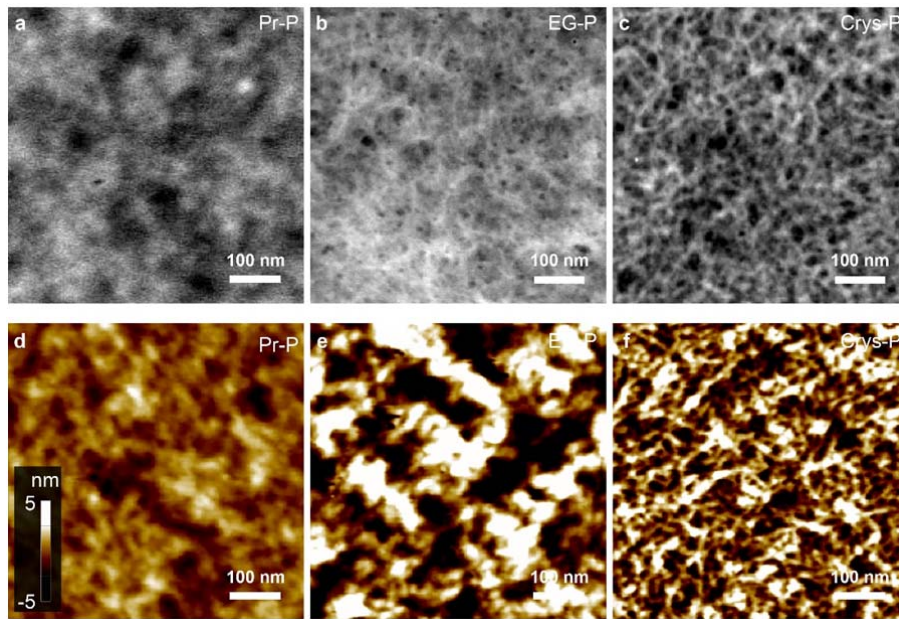
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38 **Supplementary Figure 2.** Thermogravimetric analysis (TGA) curves of PEDOT:PSS films.

39 The inset shows magnified plots at the low-temperature region.

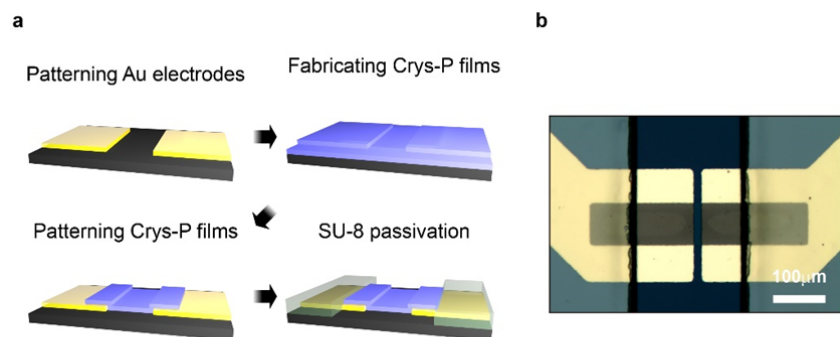
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Supplementary Figure 3. The microscopic morphologies of PEDOT:PSS films (a - c)

High-angle annular dark-field scanning transmission electron microscope (HAADF-STEM) and (d - f) Atomic force microscope (AFM) images showing the surface nanostructures of Pr-P, EG-P, and Crys-P films.

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60 **Supplementary Figure 4. Fabrication of PEDOT:PSS organic electrochemical transistor**

61 **(OECTs)** (a) Fabrication procedures for crystallized PEDOT:PSS (Crys-P) OECTs and (b)

62 the optical micrograph of Crys-P OECTs after PEDOT:PSS layer patterning and SU-8

63 passivation.

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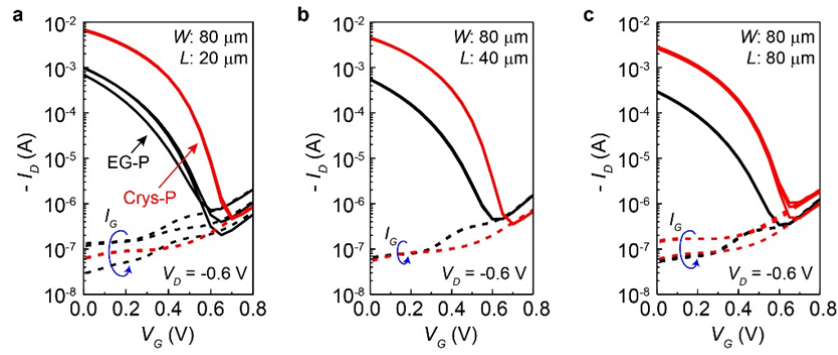
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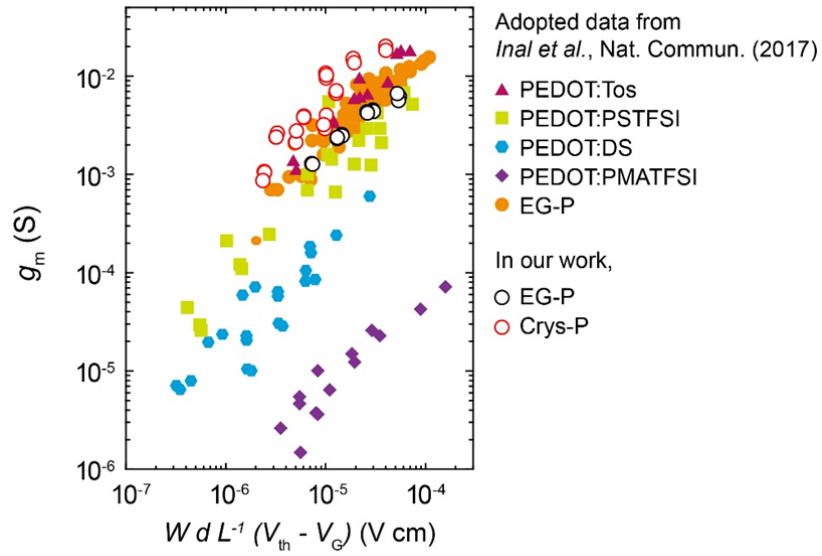
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72 **Supplementary Figure 5.** Saturation-regime transfer characteristics of EG-P (black) and

73 Crys-P (red) OECT devices with various channel length while V_D was fixed at -0.6 V.

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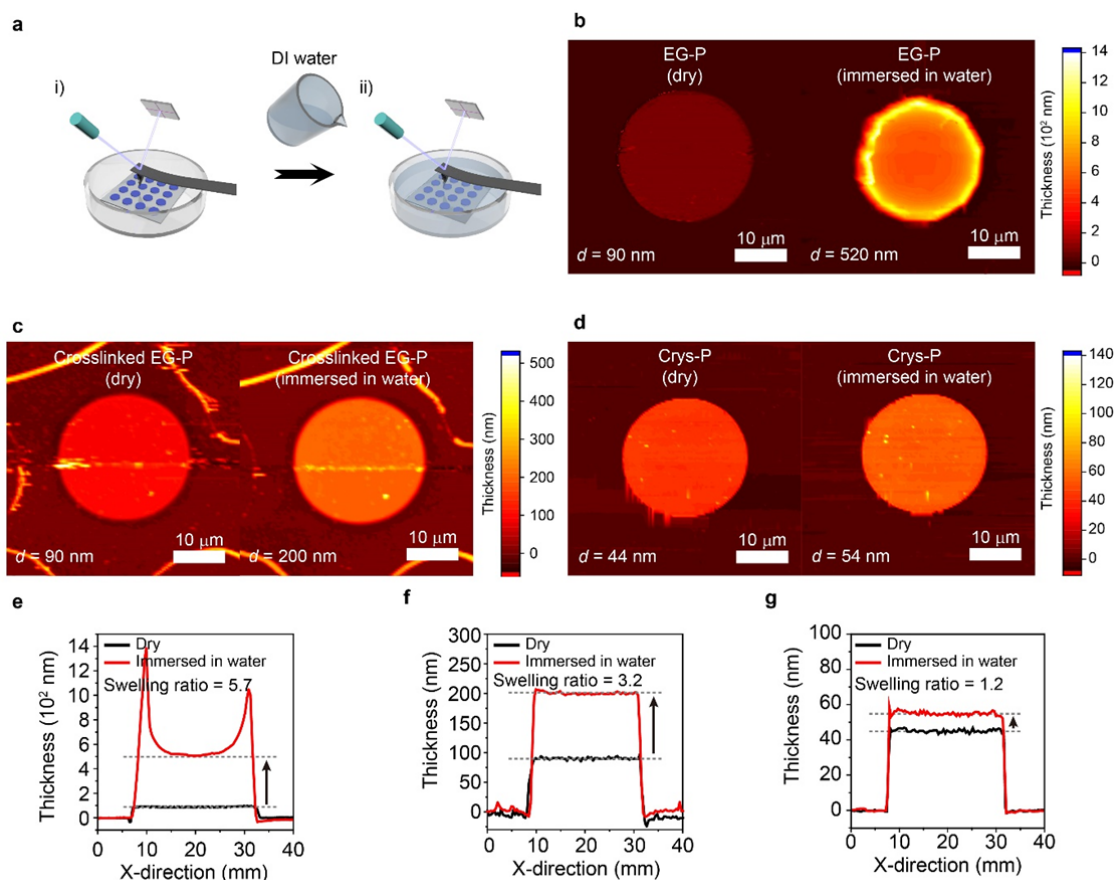
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78 **Supplementary Figure 6.** Transconductance (g_m) of OECTs as a function of operation
 79 voltage and channel geometry. The OECT data from PEDOT:Tos, PEDOT:PSTFSI,
 80 PEDOT:DS, PEDOT:PMATFSI, and EG-P were adopted from [1].

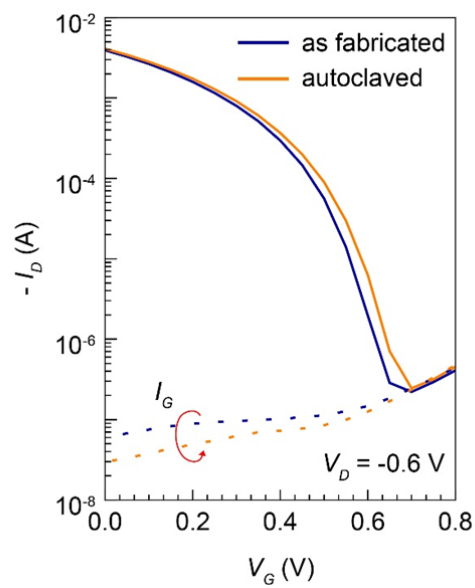
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85 **Supplementary Figure 7. The film swelling of PEDOT:PSS films** (a) A schematic of
 86 measuring the film swelling ratio based on dry and liquid AFM measurements. Comparison
 87 of the difference between dry and wet film thickness in (b, e) EG-P, (c, f) chemically
 88 crosslinked EG-P, and (d, g) Crys-P. The circular patterns of PEDOT:PSS films were
 89 generated by photolithography and scanned by either dry and liquid AFM. The swelling ratio
 90 is calculated by dividing wet film thickness by dry film thickness.



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93 **Supplementary Figure 8.** Transfer characteristics of Crys-P OECTs before and after

94 autoclaving.

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96 **Supplementary Table 1. Electrical conductivities of various PEDOT:PSS films**

Materials	Electrical conductivity (S/cm)*	97
Pr-P	1.7 ± 0.12	98
EG-P	590 ± 20	
Crys-P	4100 ± 98	99

* The average of three sample metrics in conjunction with the corresponding standard deviation were presented100

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104 **Supplementary Table 2. The figure-of-merits of OECTs made of PEDOT-based**
 105 **materials.**

Materials/Formulation	C^* (F cm ⁻³)	$[\mu C^*]_{\text{OECT}}$ (F cm ⁻¹ V ⁻¹ s ⁻¹)
PEDOT:Tos	136 ± 50	72 ± 14
PEDOT:PSTFSiLi100	26 ± 10	20 ± 1.6
PEDOT:DS + EG	65 ± 46	2.2 ± 0.9
PEDOT:PMATFSiLi80	27 ± 7	0.15 ± 0.01
PEDOT:PSS + EG	39 ± 3	47 ± 6
EG-P (Our result)	31 ± 0.79	100 ± 7
Crys-P	113 ± 1.38	490 ± 41

The volumetric capacitance and $[\mu C^*]$ data of PEDOT:Tos, PEDOT:PSTFSiLi100, PEDOT:DS + EG, PEDOT:PMATFSiLi80, and PEDOT:PSS + EG are adopted from [1]. Tosylate (Tos), PSTFSiLi100, dextran sulfate (DS), PMATFSiLi80, and poly(styrene sulfonate) (PSS) are various molecular, polymeric, and biological anionic dopants complexed with PEDOT. Ethylene glycol (EG) is a co-solvent additive known to improve electronic conductivity of polymer films.

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107 **Supplementary References**

- 108 1. Inal, S., Malliaras, G. G. & Rivnay, J. Benchmarking organic mixed conductors for
 109 transistors. *Nat. Commun.* **8**, 1767 (2017).

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